

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Werner Ertle et al.	Examiner:	Robert T. Huber
Serial No.:	10/522,502	Group Art Unit:	2892
Filed:	November 11, 2005	Docket No.:	I431.124.101/FIN404PCT/US
Title:	SEMICONDUCTOR WAFER WITH ELECTRICALLY CONNECTED CONTACT AND TEST AREAS		

AMENDMENT AND RESPONSE

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment and Response is submitted in conjunction with a Request for Continued Examination (RCE) under 37 CFR 1.114 in reply to the Final Office Action mailed July 26, 2010, and the Advisory Action mailed October 8, 2010. Please amend the above-identified patent application as follows: